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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Patent Application of

KOBAYASHI, S.

Atty. Ref.: 900-471

Serial No.

10/632,850

Group:

Filed:

August 4, 2003

Examiner:

For:

MASK PATTERN AND METHOD FOR FORMING

RESIST PATTERN USING MASK PATTERN THEREOF

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Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

STATUS INQUIRY

An application was filed on August 4, 2003. However, since then applicant has not received any Official Action from the Patent Office regarding the application. Inquiry is made as to when an Action will be forthcoming. Please direct any response to this inquiry to Linda Hull at telephone number (703) 816-4127.

Respectfully submitted,

NIXON & VANDERHYE P.C.

January 28, 2005

By:

H. Warren Burnam, Jr.

Reg. No. 29,366

HWB:lsh

1100 North Glebe Road, 8th Floor

Arlington, VA 22201-4714

Telephone: (703) 816-4000

Facsimile: (703) 816-4100